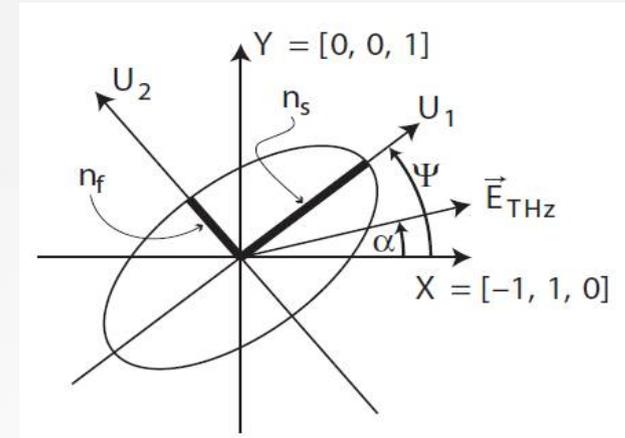
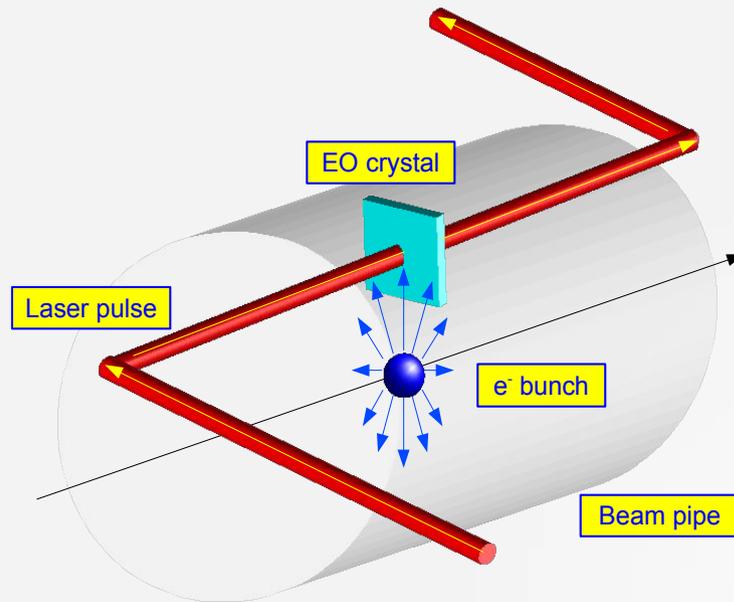


# First single-shot and non-intercepting longitudinal bunch diagnostics for comb-like beams by Electro-Optic Sampling

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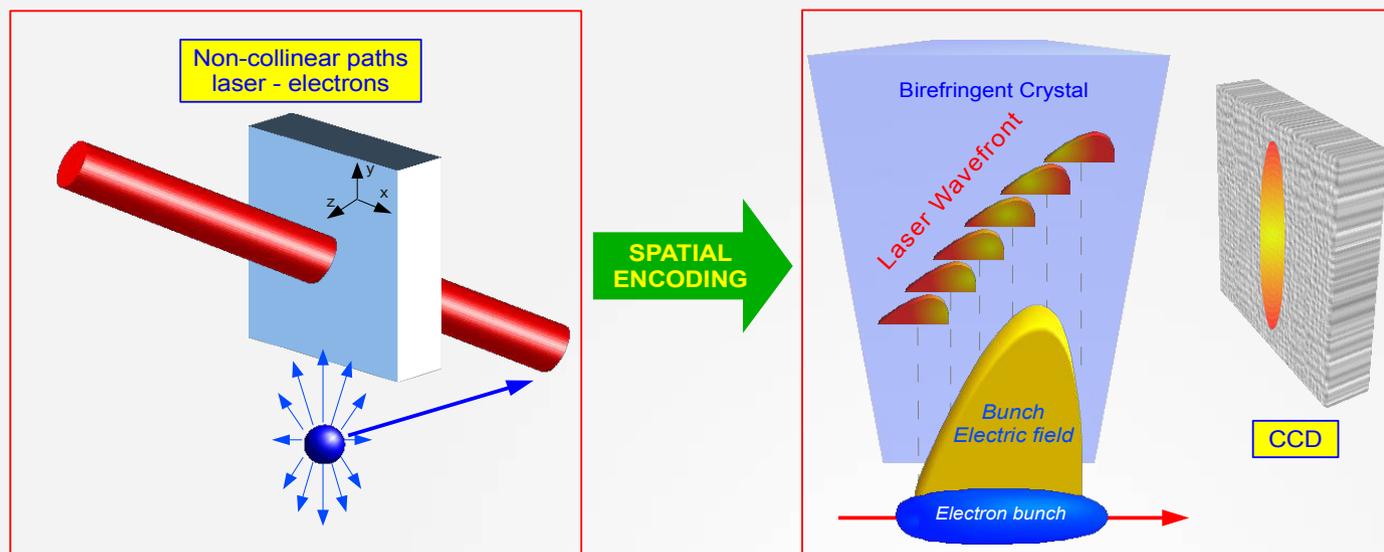
# Electro-Optical Sampling



$$\Gamma(\alpha) = \frac{\omega d}{c} (n_1 - n_2) = \frac{\omega d}{2c} n_0^3 r_4 E_{THz} \sqrt{1 + 3\cos^2 \alpha}$$

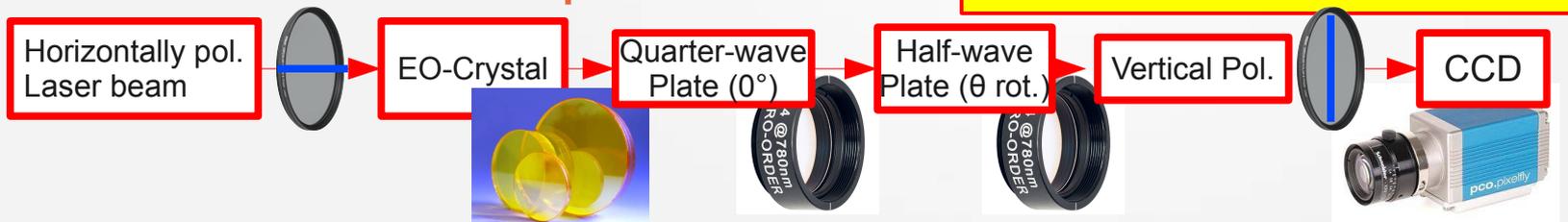
- **PWFA**: need to correlate **incoming** and **outgoing** beams from the plasma
  - non-intercepting & single-shot diagnostics for beams to be injected in **plasma**.
- **Electro-Optical Sampling (EOS)** to measure **bunch longitudinal profile** using nonlinear crystals (ZnTe, GaP)
- Benefits: **single shot, non-intercepting**, time resolution ( $\sim 50$  fs).  
 Disadvantages: small signals (low SNR), complex layout, costs.

# EOS Spatial Encoding Setup



- **Laser crosses the crystal with an incident angle of 30°** → one side of the laser pulse arrives **earlier** on the EO crystal than the other by a time difference  $\Delta t$ .
- **Coulomb field inducing birefringence is encoded in the spatial profile of laser pulse**
- Benefits: **simple, no high energy laser needed.**
- Drawbacks: **poor surface quality of EO crystals.**

## Near Crossed Polarizer Setup



# SPARC\_LAB Layout

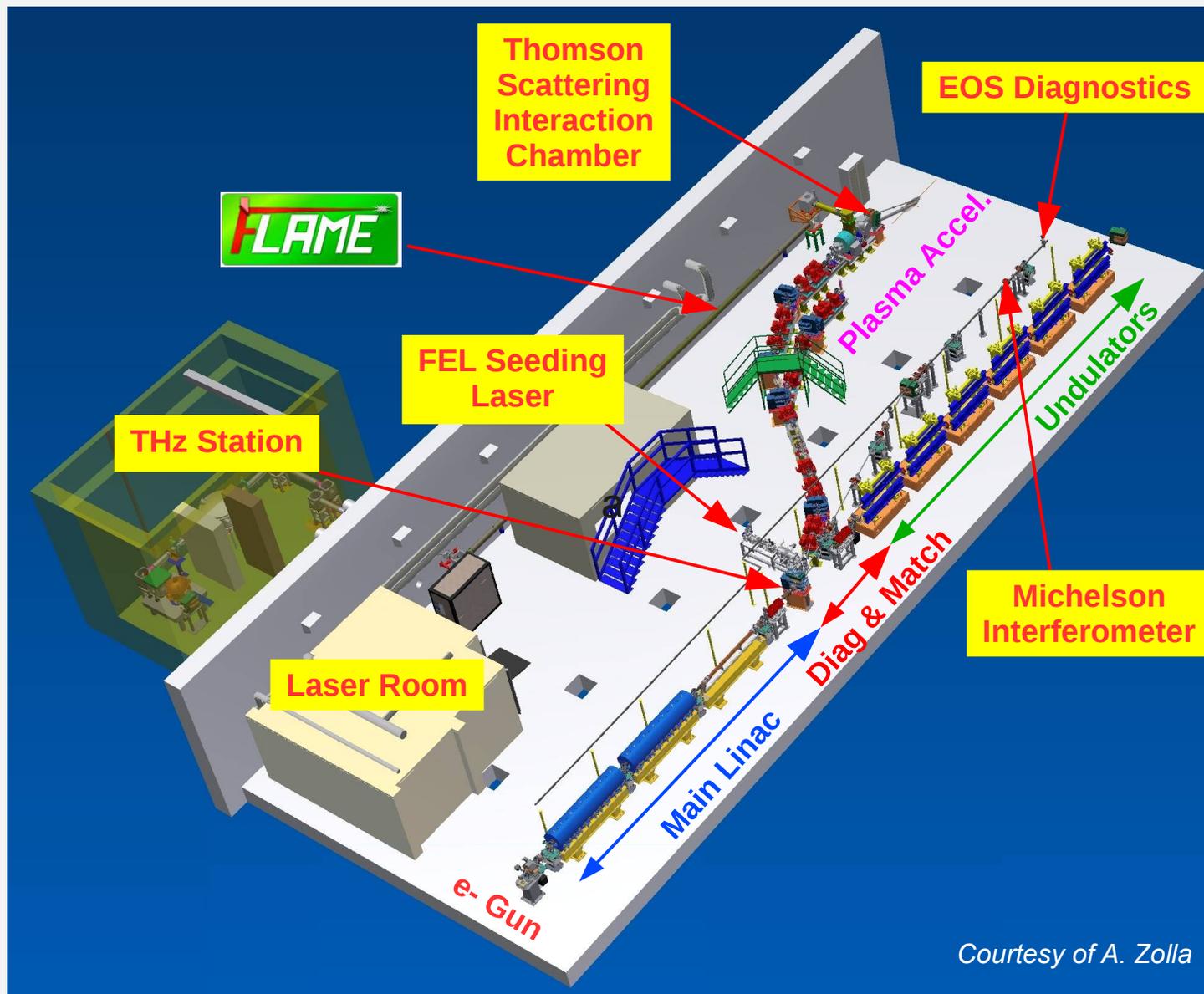
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Electro-Optic  
Sampling

Experimental  
Apparatus

2-pulses  
COMB beam

Experimental  
Results



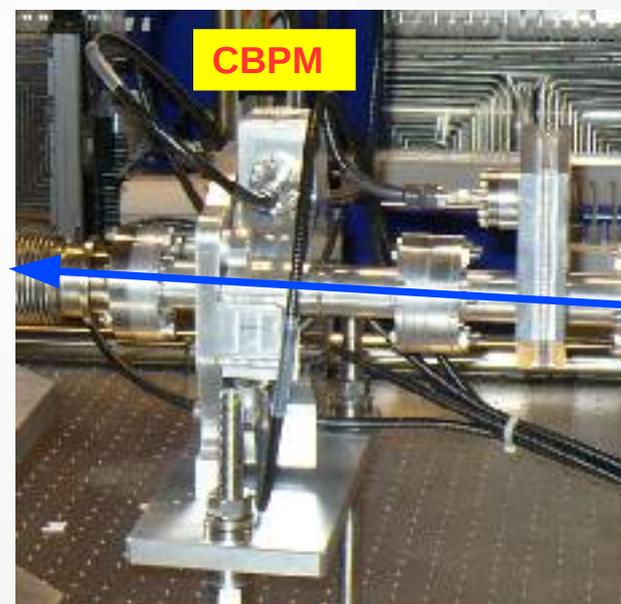
Courtesy of A. Zolla

# Laser-electrons synchronization

- EOS uses the SPARC\_LAB ptc. laser
  - 800nm, 60fs (rms, T.L.), up to 500μJ pulse energy, 10Hz.
- Transfer Line of 34m installed.
- Benefits
  - Simplified EOS layout setup
  - **Independent laser system**
  - High energy available
  - **Self-synchronized with e-beam**
    - 1 laser pulse per 1 e- bunch
    - **Intensified Fast Gated CGD**



EOS Laser Transfer Line



CBPM

## Synchronization laser-electrons

- Laser Time Arrival Monitor: 30ps risetime photodiode.



G4176-03

Item	Symbol	Condition	Value	Unit
Spectral Response Range	$\lambda$	$V_b = 7 \text{ V}$	450 to 870	nm
Peak Response Wavelength	$\lambda_p$	$V_b = 7 \text{ V}$	850	nm
Effective Sensitive Area	A		$0.2 \times 0.2$	mm <sup>2</sup>
Chip Size			$1 \times 1$	mm <sup>2</sup>

- Bunch Time Arrival Monitor: 4GHz Cavity-BPM.

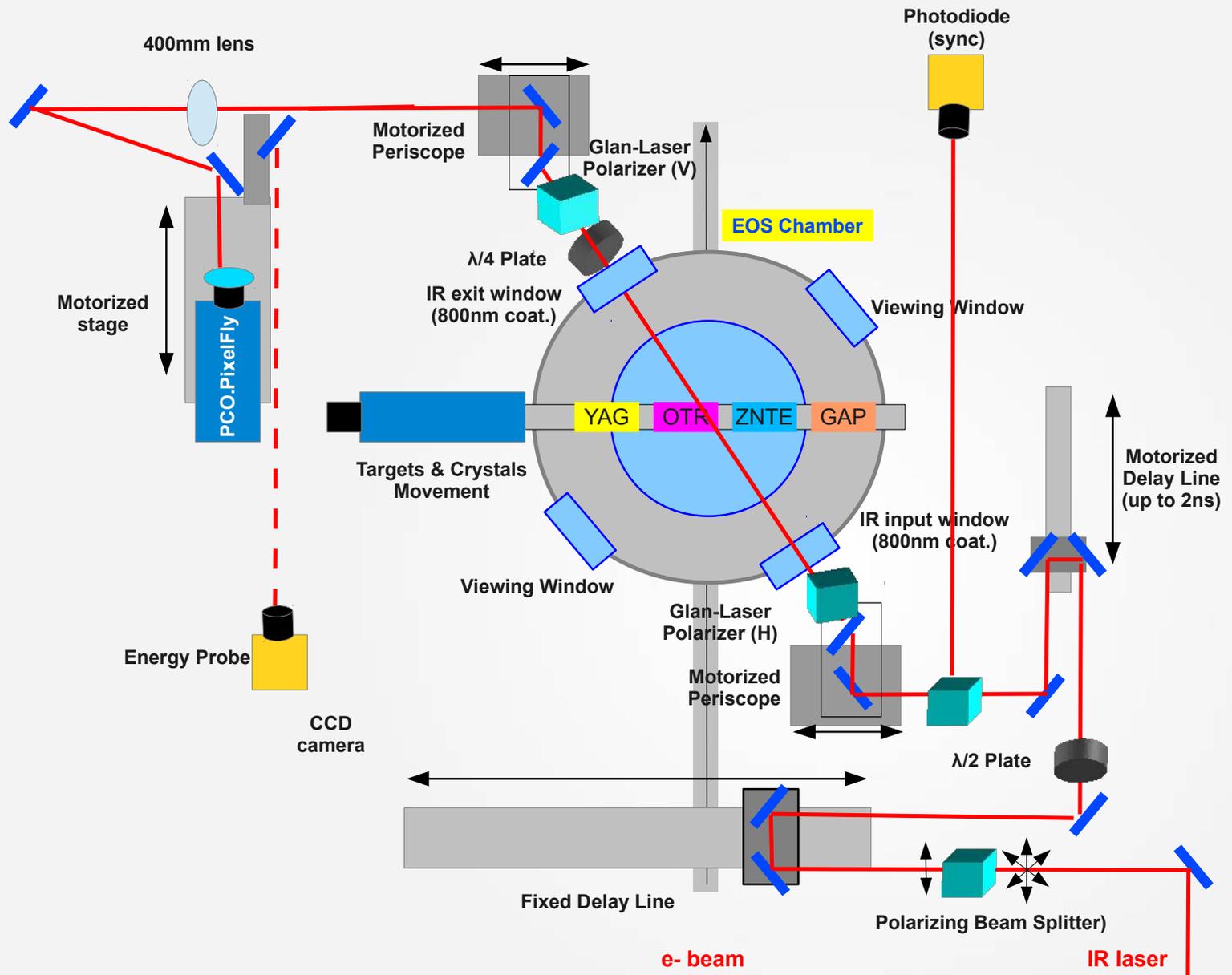
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Results

# EOS optical setup



Electro-Optic Sampling

Experimental Apparatus

2-pulses COMB beam

Experimental Results

# EOS diagnostics chamber

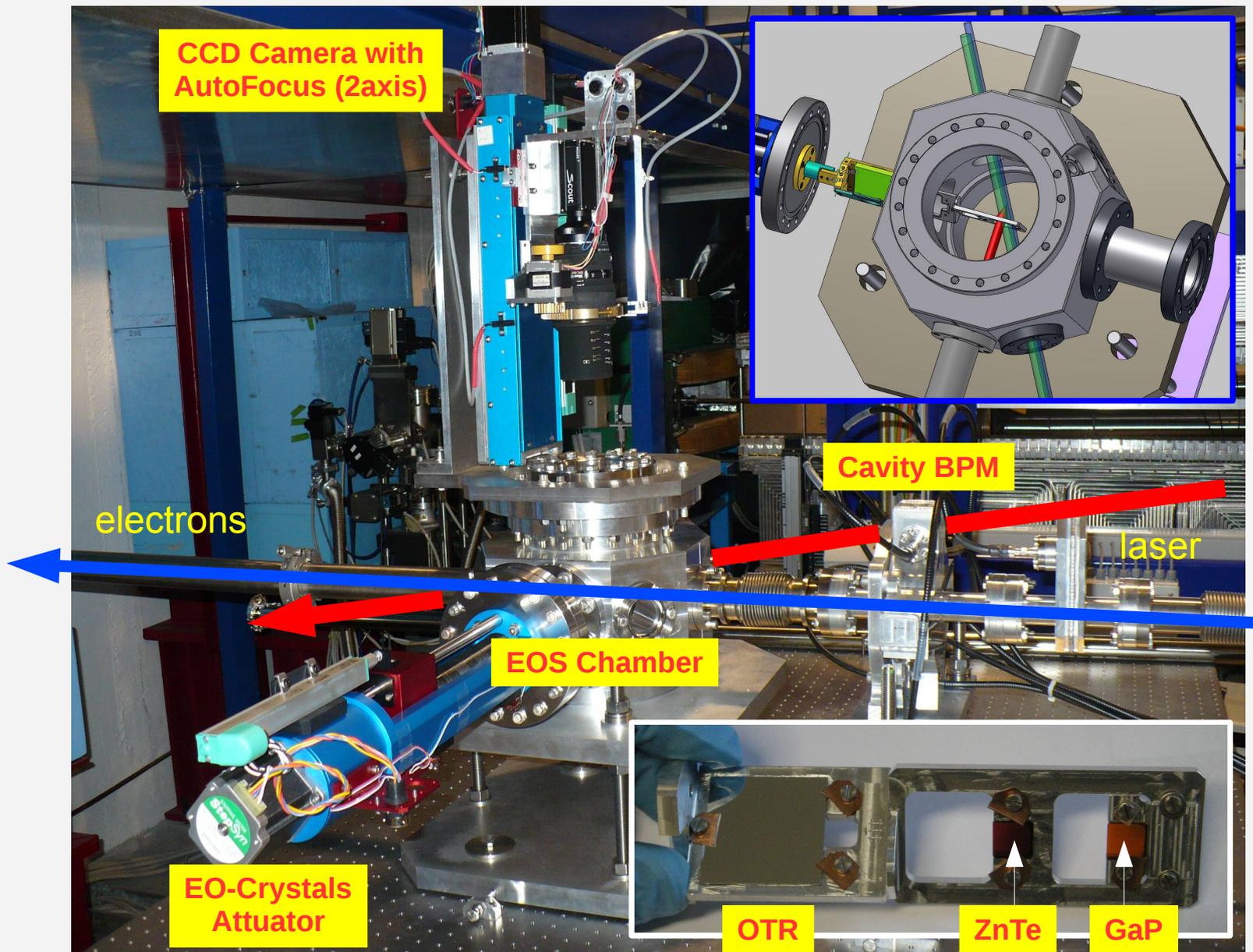
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# Longitudinal Phase Space

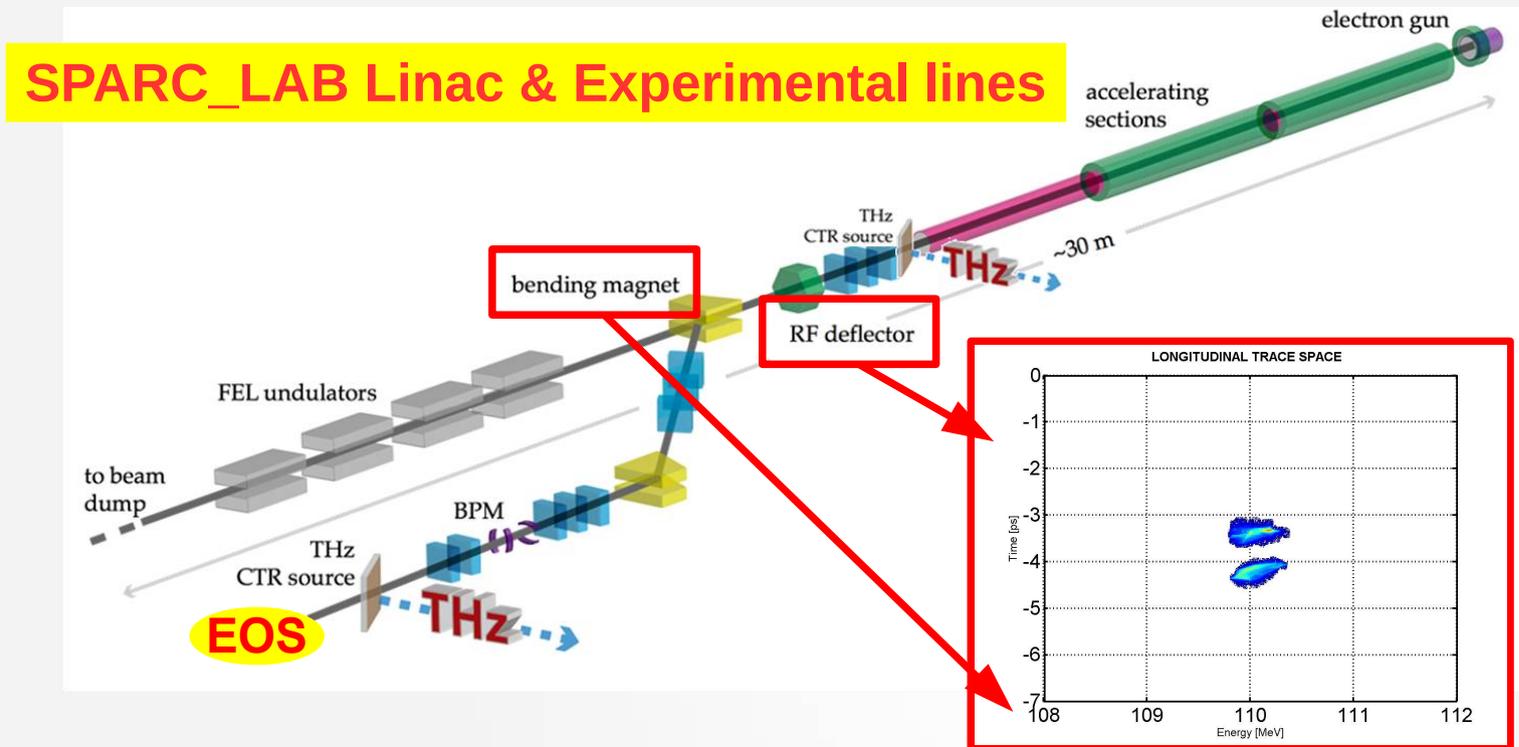
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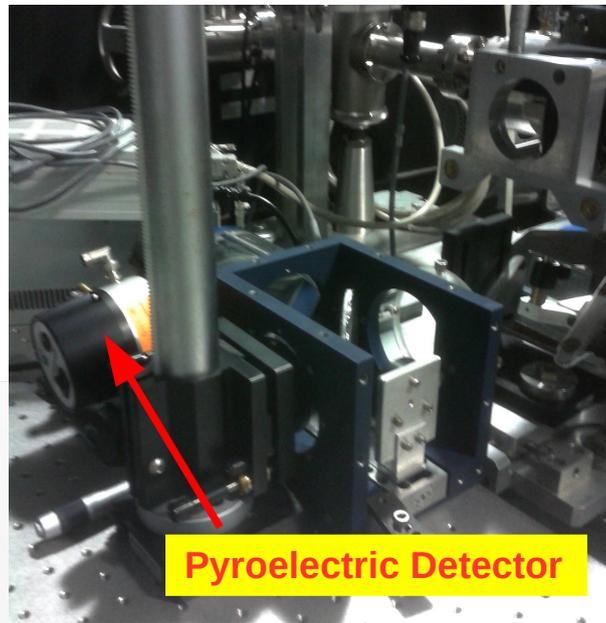
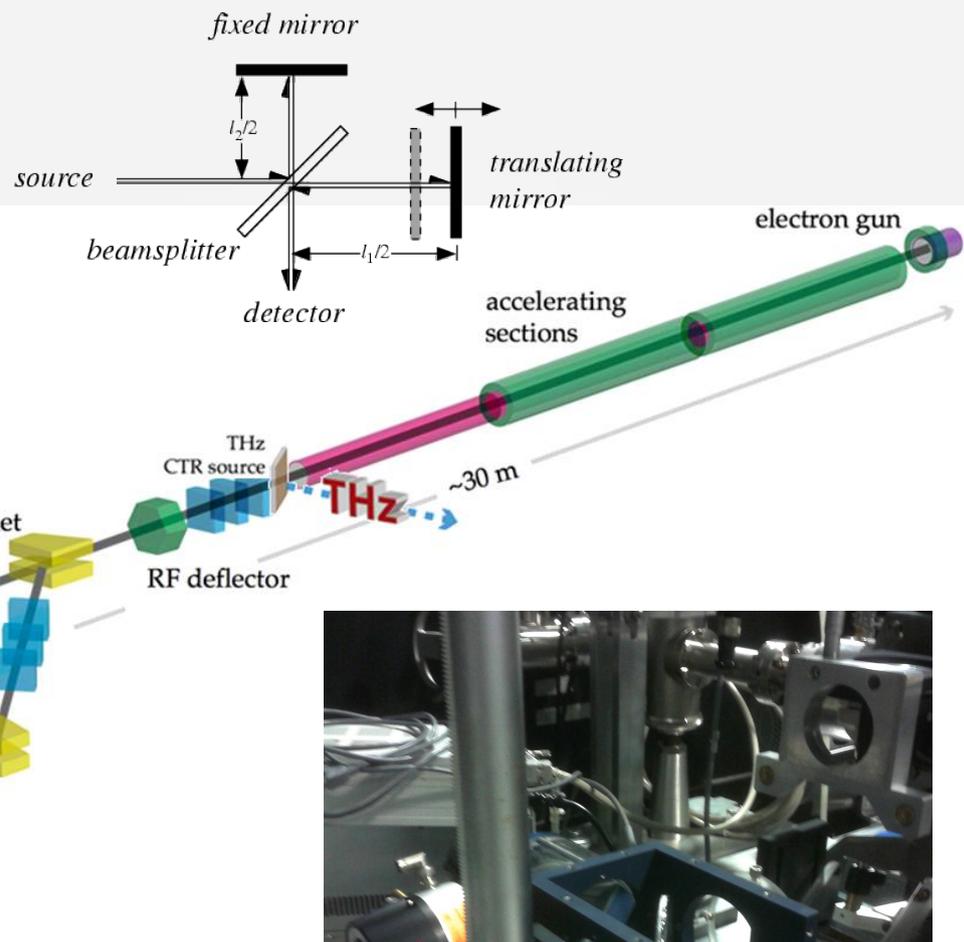
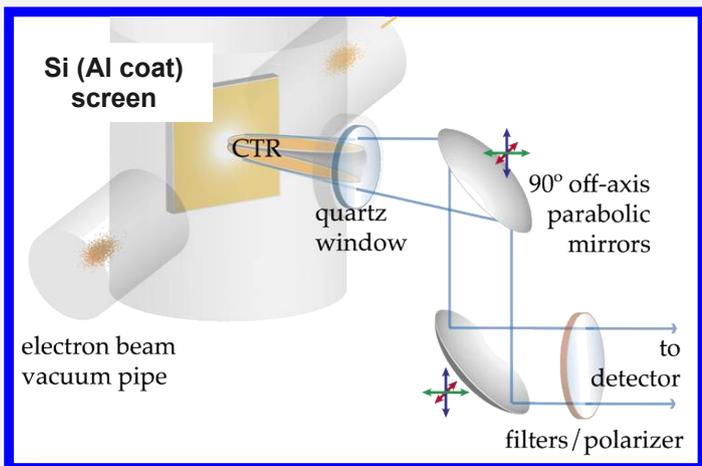
2-pulses  
COMB beam

Experimental  
Results



- Charge: 160pC total (80pC + 80pC)
- Energy: 110MeV
- Overall emittance: 2.29mm mrad (Y), 2.56mm mrad (X)
- 2-bunches distance: (830±30) fs (rms)
- Bunch lengths: (64±8) fs, (52±8) fs (rms)

# Michelson Interferometer results



THz Detector: 0.5 ÷ 30 THz  
Beam Splitter: Mylar 12μm  
Quartz Window: <3.8 THz

- Electro-Optic Sampling
- Experimental Apparatus
- 2-pulses COMB beam
- Experimental Results

# Michelson Interferometer results

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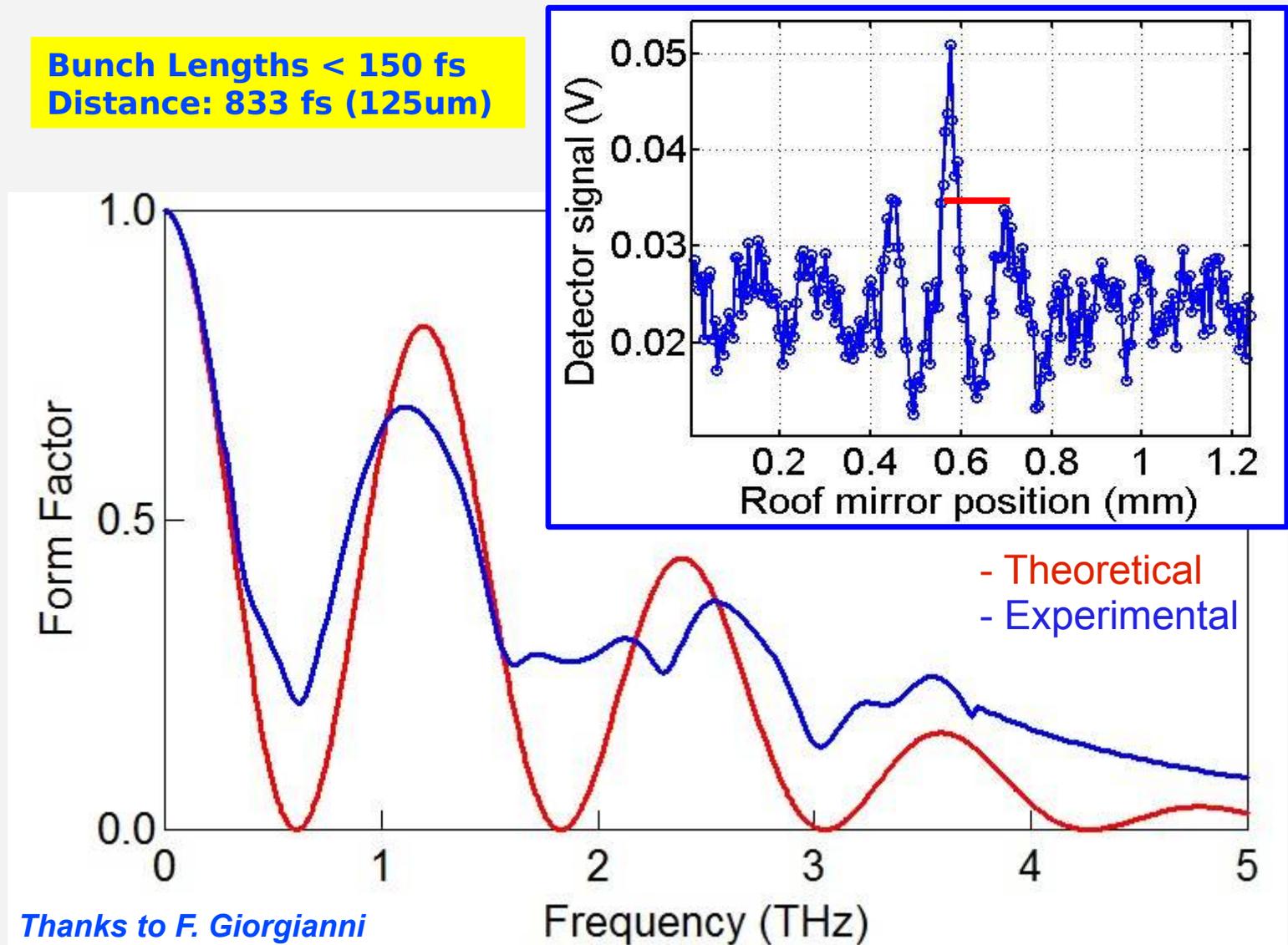
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COMB beam

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Results

Bunch Lengths < 150 fs  
Distance: 833 fs (125um)



# EOS Current Parameters

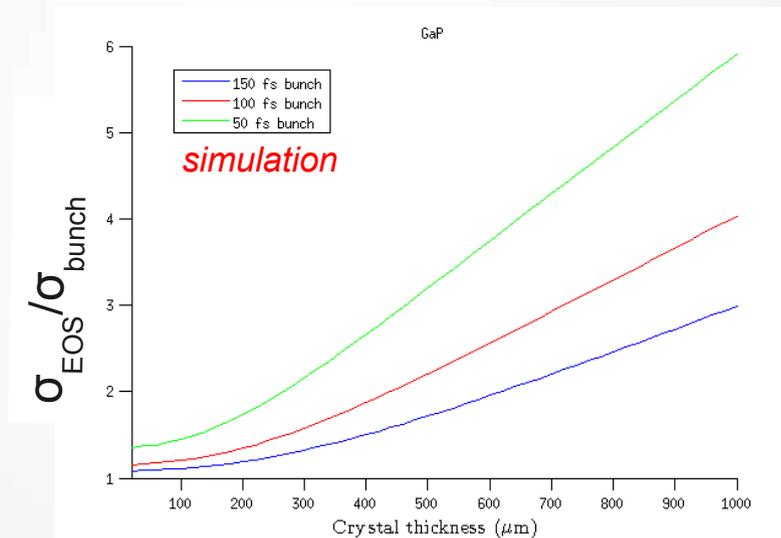
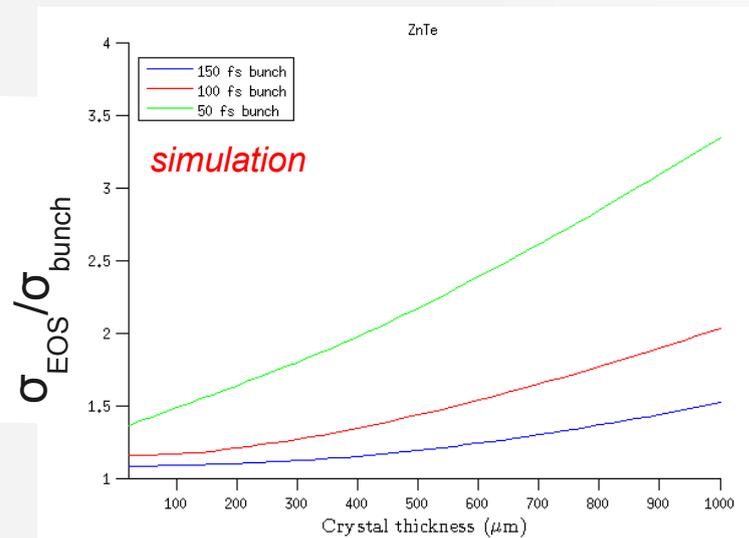
- Ti:Sa SPARC\_LAB photocathode laser
  - *Pulse duration:* **130 fs (rms)**
  - *Energy:* **200 nJ**
  - *Spot diameter:* **5 mm (~10 ps time window)**
- CCD resolution: **1 pixel  $\approx$  17 fs**
- Crystals  $10 \times 10 \text{ mm}^2$  (provided by IngCrys Ltd.)
  - ZnTe (400 $\mu\text{m}$ ), GaP (500 $\mu\text{m}$ )
  - **140 fs (ZnTe), 250 fs (GaP) rms** (THz – laser velocity mismatch)

Electro-Optic  
Sampling

Experimental  
Apparatus

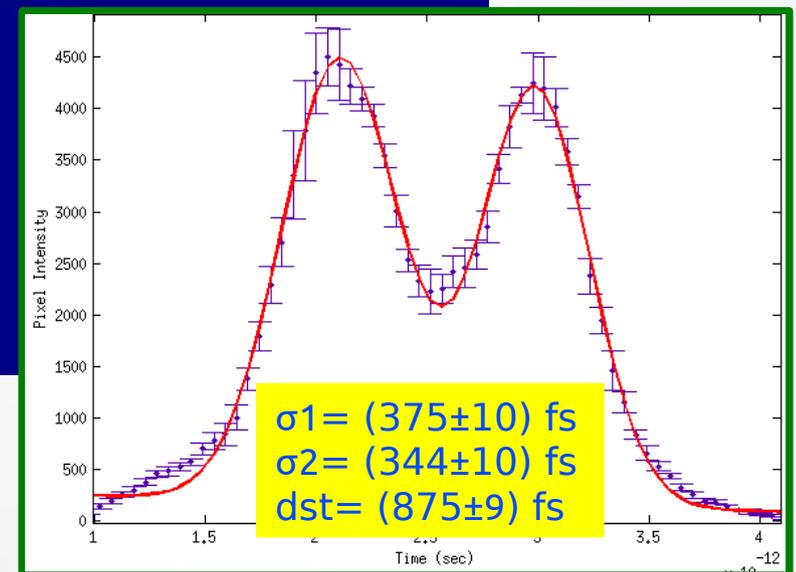
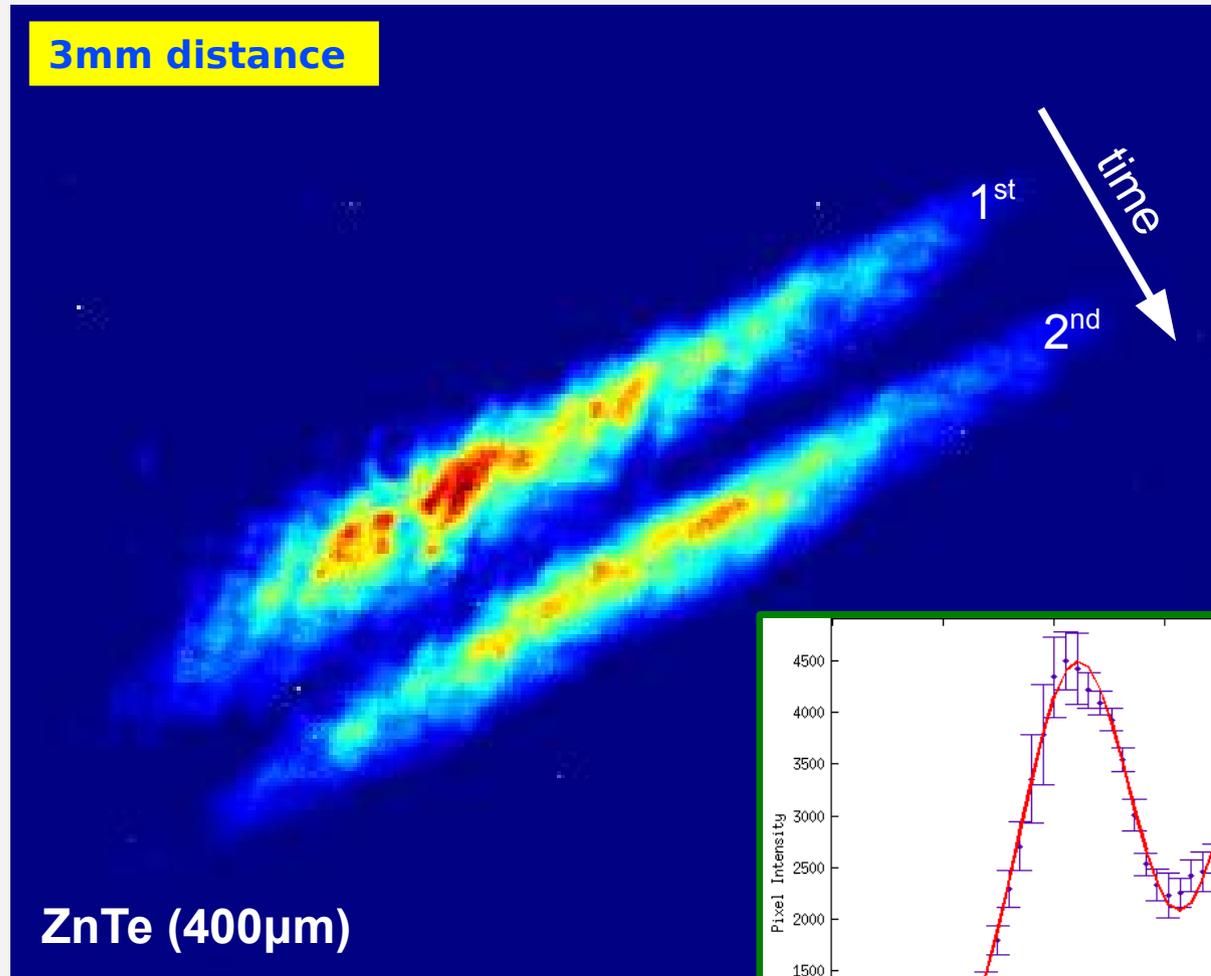
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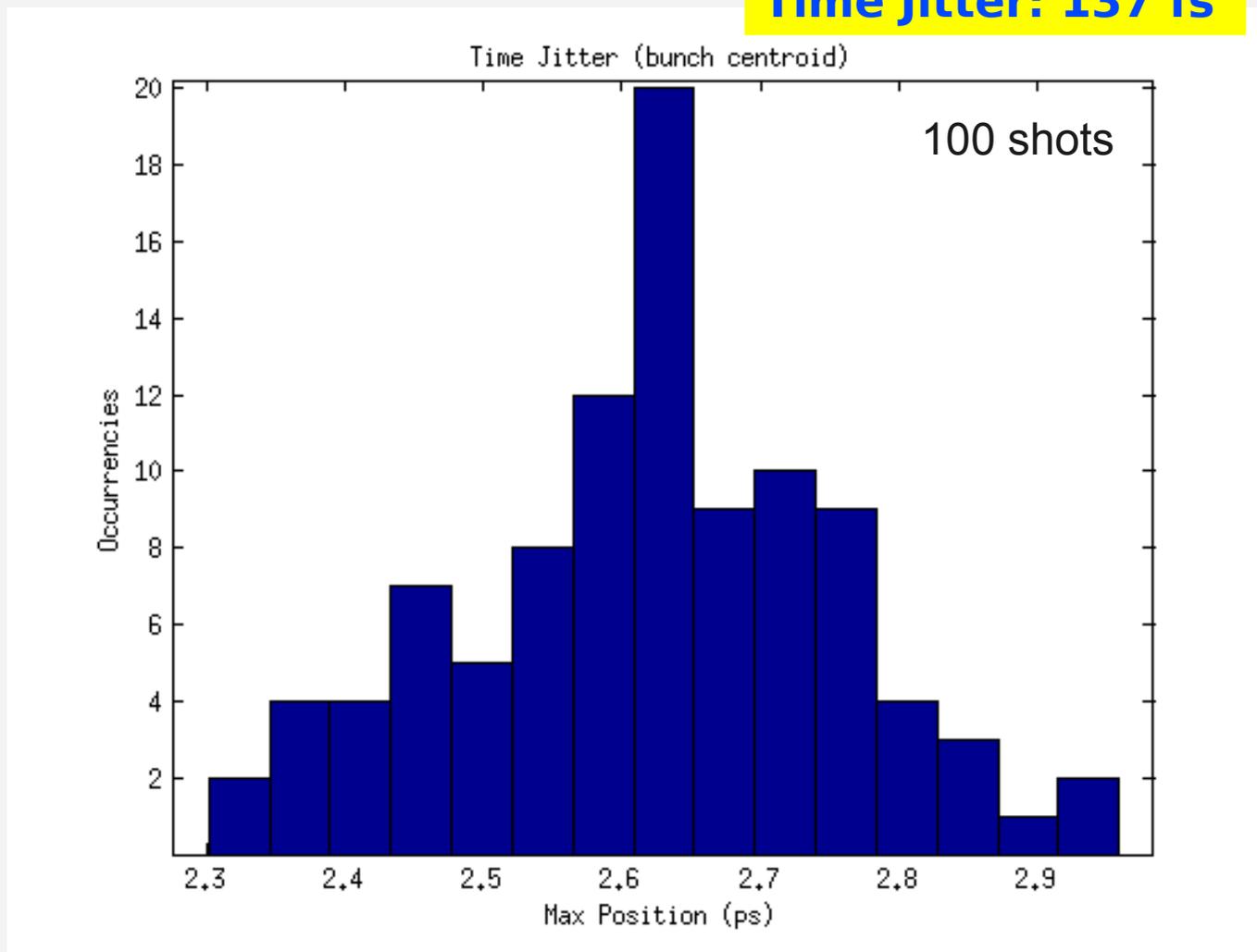
- Better resolution limit  $\sigma_{\text{lim}}$  with thinner crystals (but lower signals!)

# Very preliminary EOS results



# Time Jitter evaluation with EOS

**Time Jitter: 137 fs**



# Conclusions & Outlooks

- ✓ EOS Monitor is a useful diagnostics **to measure lengths and spacing** of single and multi-bunch electron beams.
- ✓ It can be used as a **time-stamp** and/or to evaluate the RF **time jitter**.
- ✓ Bunch spacing is well reproduced.
- × As expected the bunch lengths were too short to be correctly measured → improvements needed for sub-100fs bunches:
  - *Shorter laser pulse* → make a pulse compressor to achieve laser TF pulse length of 60 fs (rms).
  - *Use thinner crystals* → with 100um thicknesses we have ~110 fs (ZnTe) and **~50 fs (GaP)** rms resolutions.
    - Drawback: very low signals!
  - Exploring different EO crystals...

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**Thank you for  
your attention!**